

D. PERSAUD

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kiyoshi UCHIKAWA

10/588,730

Filed: October 18, 2007

Application No.: Examiner:

Group Art Unit: 2882

Docket No.: 129041

EXPOSURE METHOD AND APPARATUS, AND DEVICE PRODUCTION METHOD

<u>AMENDMENT</u>

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

For:

In reply to the May 26, 2010 Office Action, the period for reply being extended by the attached Petition for Extension of Time, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and Remarks.